



Attorney Docket No.: PATENT
SSI-08500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Group Art Unit: 3746
William Dale Jones)	Examiner:
Serial No.: 10/630,649)	<u>TRANSMITTAL LETTER</u>
Filed: July 29, 2003)	162 N. Wolfe Road
For: CONTROL OF FLUID FLOW IN)	Sunnyvale, CA 94086
THE PROCESSING OF AN)	(408) 530-9700
OBJECT WITH A FLUID)	Customer No.: 28960

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

Enclosed please find an Information Disclosure Statement and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office.

You will also find enclosed the associated Transmittals, Electronic Information, Disclosure Statements, and United States Patent and Trademark Office Acknowledgment Receipts for the electronically filed Information Disclosure Statement (EFS ID #53480); (EFS ID #53481); (EFS ID #53482); (EFS ID #53483); (EFS ID #53484); (EFS ID #53486); and (EFS ID #53487) filed on January 12, 2004.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 1-12-04

By: Thomas B. Haverstock
Thomas B. Haverstock
Reg. No.: 32,571

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP.

Date: 1-12-04 By: [Signature]

Attorneys for Applicant



Attorney Docket No.: PATENT
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In re Application of:

William Dale Jones

Serial No.: 10/630,649

Filed: July 29, 2003

For: **CONTROL OF FLUID FLOW IN
THE PROCESSING OF AN
OBJECT WITH A FLUID**

) Group Art Unit: 3746

) Examiner:

) **INFORMATION DISCLOSURE**
) **STATEMENT**

) 162 N. Wolfe Road
) Sunnyvale, CA 94086
) (408) 530-9700

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

United States Patents or Published Patent Applications have been filed electronically (EFS ID #53480); (EFS ID #53481); (EFS ID #53482); (EFS ID #53483); (EFS ID #53484); (EFS ID #53486); and (EFS ID #53487). Applicants have become aware of the following printed publication which may be material to the examination of this application:

- Chinese Publication No. CN 1399790 A;
- German Publication No. DE 36 08 783 A1;
- German Publication No. DE 39 04 514 C2;
- German Publication No. DE 39 06 724 C2;
- German Publication No. DE 39 06 735 C2;
- German Publication No. DE 39 06 737 A1;
- German Publication No. DE 40 04 111 C2;
- German Publication No. DE 43 44 021 A1;
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- European Publication No. EP 0 829 312 A2;
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- PCT Publication No. WO 90/13675;
- PCT Publication No. WO 91/12629;
- PCT Publication No. WO 93/14255;
- PCT Publication No. WO 93/14259;
- PCT Publication No. WO 93/20116;
- PCT Publication No. WO 96/27704;
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This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 1-12-04

By: Thomas B. Haverstock
Thomas B. Haverstock
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Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(a))

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HAVERSTOCK & OWENS LLP.
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use Several Sheets If Necessary)

Applicant: William Dale Jones

Filing Date: July 29, 2003

Group Art Unit: 3746

(37 CFR § 1.98(b))

FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

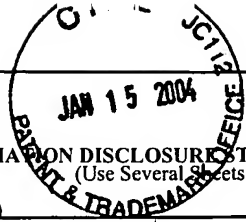
		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
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	AB	DE 36 08 783 A1	09/17/87	Germany	C30B	25/12		X
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INFORMATION ON DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary)						Applicant: William Dale Jones			
(37 CFR § 1.98(h))						Filing Date: July 29, 2003		Group Art Unit: 3746	
FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS									
		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation		
							Yes	No	
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FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
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	CT	WO 01/85391 A2	11/15/01	PCT	B24B			X
	CU	WO 01/94782 A3	12/13/01	PCT	F04B	43/02		X
	CV	WO 02/09894 A2	02/07/02	PCT	B08B			X
	CW	WO 02/11191 A2	02/07/02	PCT	H01L	21/00		X
	CX	WO 02/16051 A2	02/28/02	PCT	B05D			X
	CY	WO 03/030219 A2	10/04/03	PCT	H01L			X

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	DA	"Los Alamos National Laboratory," Solid State Technology, pp. S10 & S14, October 1998.
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	DC	Guan, Z. et al., "Fluorocarbon-Based Heterophase Polymeric Materials. 1. Block Copolymer Surfactants for Carbon Dioxide Applications," Macromolecules, Vol. 27, 1994, pp 5527-5532.
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	DG	Kirk-Othmer, "Alcohol Fuels to Toxicology," Encyclopedia of Chemical Terminology, 3rd ed., Supplement Volume, New York: John Wiley & Sons, 1984, pp. 872-893.
	DH	"Cleaning with Supercritical CO ₂ ," NASA Tech Briefs, MFS-29611, Marshall Space Flight Center, Alabama, March 1979.
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	DL	Sun, Y.P. et al., "Preparation of Polymer-Protected Semiconductor Nanoparticles Through the Rapid Expansion of Supercritical Fluid Solution," Chemical Physics Letters, pp. 585-588, May 22, 1998.
	DM	Jackson, K. et al., "Surfactants and Micromulsions in Supercritical Fluids," Supercritical Fluid Cleaning. Noyes Publications, Westwood, NJ, pp. 87-120, Spring 1998.
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Examiner

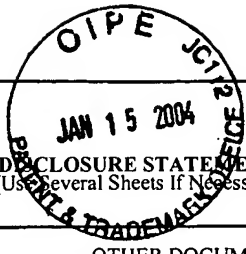
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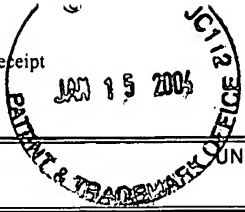
EXAMINER:

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FORM PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office		Attorney Docket No.: SSI-08500	Serial No.: 10/630,649
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets If Necessary)				Applicant: William Dale Jones	
				Filing Date: July 29, 2003	Group Art Unit: 3746
(37 CFR § 1.98(h))					
OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)					
	DU	Tomioka Y, et al., "Decomposition of Tetramethylammonium (TMA) in a Positive Photo-resist Developer by Supercritical Water," Abstracts of Papers 214 th ACS Natl Meeting, American Chemical Society, Abstract no. 108, September 7, 1997.			
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	EC	Gabor, A. et al., "Block and Random Copolymer resists Designed for 193 nm Lithography and Environmentally Friendly Supercritical CO ₂ Development," SPIE, Vol. 2724, pp. 410-417, Jun. 1996.			
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	EI	Gallagher-Wetmore, P. et al., "Supercritical Fluid Processing: A New Dry Technique for Photoresist Developing," SPIE Vol. 2438, pp.694-708, Jun. 1995.			
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	EU	Brokamp, T. et al., "Synthese und Kristallstruktur Eines Gemischtvalenten Lithium-Tantalnitrids Li ₂ Ta ₃ N ₅ ," J. Alloys and Compounds, Vol. 176. pp. 47-60, 1991.			
	EV	Hybertson, B.M. et al., "Deposition of Palladium Films by a Novel Supercritical Fluid Transport Chemical Deposition Process," Mat. Res. Bull., Vol. 26, pp. 1127-1133, 1991.			
	EW	Ziger, D. H. et al., "Compressed Fluid Technology: Application to RIE-Developed Resists," AiChE Jour., Vol. 33, No. 10, pp. 1585- 1591, October 1987.			
	EX	Matson, D.W. et al., "Rapid Expansion of Supercritical Fluid Solutions: Solute Formation of Powders, Thin Films, and Fibers," Ind. Eng. Chem. Res., Vol. 26, No. 11, pp. 2298-2306, 1987.			
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(37 CFR § 1.98(b))				Filing Date: July 29, 2003	
OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)					
	EY	Tolley, W.K. et al., "Stripping Organics from Metal and Mineral Surfaces using Supercritical Fluids," Separation Science and Technology, Vol. 22, pp. 1087-1101, 1987.			
	EZ	"Final Report on the Safety Assessment of Propylene Carbonate", J. American College of Toxicology, Vol. 6, No. 1, pp. 23-51, 1987.			
	FA	"Porous Xerogel Films as Ultra-Low Permittivity Dielectrics for ULSI Interconnect Applications", Materials Research Society, pp. 463-469, 1997.			
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Electronic Version 1.1

Stylesheet Version v1.1.1

Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID									
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Date:	2003-07-29						
First Named Applicant:	William Dale Jones						
Confirmation Number:	8266						
Attorney Docket Number:							
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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney					

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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Confirmation Number:	8266						
First Named Applicant:	William Jones						
Attorney Docket Number:							
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US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
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Remarks

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Confirmation Number:	8266						
Attorney Docket Number:							
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>							
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Submitted by:	Elec. Sign.	Sign. Capacity					
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney					

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Comments	

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v1.8

Stylesheet Version v1.8.0

Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID						
Application Number:	10/630649	*10/630649*					
Confirmation Number:	8266						
First Named Applicant:	William Jones						
Attorney Docket Number:							
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Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
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	1	5044871	1991-09-03	Davis et al.			
	2	5062770	1991-11-05	Story et al.			
	3	5068040	1991-11-26	Jackson			
	4	5071485	1991-12-10	Matthews et al.			
	5	5105556	1992-04-21	Kurokawa et al.			
	6	5143103	1992-09-01	Basso et al.			
	7	5158704	1992-10-27	Fulton et al.			

8	5167716	1992-12-01	Boitnott et al.
9	5169296	1992-12-08	Wilden
10	5169408	1992-12-08	Biggerstaff et al.
11	5174917	1992-12-29	Monzyk
12	5185058	1993-02-09	Cathey, Jr.
13	5185296	1993-02-09	Morita et al.
14	5186718	1993-02-16	Tepman et al.
15	5188515	1993-02-23	Horn
16	5190373	1993-03-02	Dickson et al.
17	5191993	1993-03-09	Wanger et al.
18	5193560	1993-03-16	Tanaka et al.
19	5195878	1993-03-23	Sahlavo et al.
20	5196134	1993-03-23	Jackson
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22	5213485	1993-05-25	Wilden
23	5213619	1993-05-25	Jackson et al.
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25	5217043	1993-06-08	Novakovi
26	5221019	1993-06-22	Pechacek
27	5222876	1993-06-29	Budde
28	5224504	1993-07-06	Thompson et al.
29	5225173	1993-07-06	Wai
30	5236602	1993-08-17	Jackson
31	5236669	1993-08-17	Simmons et al.
32	5237824	1993-08-24	Pawliszyn
33	5238671	1993-08-24	Matson et al.
34	5240390	1993-08-31	Kvinge et al.
35	5243821	1993-09-14	Schuck et al.
36	5246500	1993-09-21	Samata et al.
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39	5261965	1993-11-16	Moslehi

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42	5269815	1993-12-14	Schlenker et al.
43	5269850	1993-12-14	Jackson
44	5274129	1993-12-28	Natale et al.
45	5280693	1994-01-25	Heudecker
46	5285352	1994-02-08	Pastore et al.
47	5288333	1994-02-22	Tanaka et al.
48	5290361	1994-03-01	Hayashida et al.
49	5294261	1994-03-15	McDermott et al.
50	5298032	1994-03-29	Schlenker et al.

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal.
The current electronic filing contains part 2 out of a total of 7 electronic filings.

Signature

Examiner Name	Date

UNITED STATES PATENT AND TRADEMARK OFFICE
ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1

Stylesheet Version v1.1.1

Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID										
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Date:	2003-07-29						
First Named Applicant:	William Dale Jones						
Confirmation Number:	8266						
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<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>							
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Attorney Docket Number:							
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11	5337446	1994-08-16	Smith et al.
12	5339844	1994-08-23	Stanford Jr. et al.
13	5352327	1994-10-04	Witowski
14	5355901	1994-10-18	Mielnik et al.
15	5356538	1994-10-18	Wal et al.
16	5364497	1994-11-15	Chau et al.
17	5368171	1994-11-29	Jackson
18	5370740	1994-12-06	Chao et al.
19	5370741	1994-12-06	Bergman
20	5370742	1994-12-06	Mitchell et al.
21	5377705	1995-01-03	Smith, Jr. et al.
22	5401322	1995-03-28	Marshall
23	5403621	1995-04-04	Jackson et al.
24	5403665	1995-04-04	Alley et al.
25	5404894	1995-04-11	Shirahwa
26	5412958	1995-05-09	Iliff et al.
27	5417768	1995-05-23	Smith, Jr. et al.
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31	5470393	1995-11-28	Fukazawa
32	5474812	1995-12-12	Truckenmuller et al.
33	5482564	1996-01-09	Douglas et al.
34	5486212	1996-01-23	Mitchell et al.
35	5494526	1996-02-27	Paranjpe
36	5500081	1996-03-19	Bergman
37	5501761	1996-03-26	Evans et al.
38	5503176	1996-04-02	Dunmire et al.
39	5505219	1996-04-09	Lansberry et al.

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41	5514220	1996-05-07	Wetmore et al.
42	5522938	1996-06-04	O'Brien
43	5526834	1996-06-18	Mielnik et al.
44	5533538	1996-07-09	Marshall
45	5547774	1996-08-20	Gimzewski et al.
46	5550211	1996-08-27	DeCrosta et al.
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48	5580846	1996-12-03	Hayashida et al.
49	5589082	1996-12-31	Lin et al.
50	5589105	1996-12-31	DeSimone et al.

Remarks

Note: Remarks are not for responding to an office action.

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The current electronic filing contains part 3 out of a total of 7 electronic filings.

Signature

Examiner Name	Date

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JAN 15 2004

UNITED STATES PATENT AND TRADEMARK OFFICE
ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1

Worksheet Version v1.1.1

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Application Number:	10/630649 *10/630649*						
Date:	2003-07-29						
First Named Applicant:	William Dale Jones						
Confirmation Number:	8266						
Attorney Docket Number:							
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>							
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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney					

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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Stylesheet Version v18.0

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InventionCONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT
WITH A FLUID

Application Number: 10/630649

10/630649

Confirmation Number: 8266

First Named Applicant: William Jones

Attorney Docket Number:

Search string: (5589224 or 5621982 or 5629918 or 5632847 or 5635463 or 5637151 or 5641887 or 5644855 or 5649809 or 5656097 or 5665527 or 5669251 or 5676705 or 5679169 or 5679171 or 5683473 or 5683977 or 5688879 or 5700379 or 5702228 or 5706319 or 5714299 or 5725987 or 5726211 or 5730874 or 5736425 or 5739223 or 5746008 or 5766367 or 5783082 or 5797719 or 5798126 or 5798438 or 5804607 or 5807607 or 5847443 or 5866005 or 5868856 or 5868862 or 5872061 or 5872257 or 5873948 or 5881577 or 5882165 or 5888050 or 5893756 or 5896870 or 5898727 or 5900107 or 5900354).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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16	5683473	1997-11-04	Jureller et al.
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Remarks

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ACKNOWLEDGEMENT RECEIPT

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Stylesheet Version v1.1.1

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Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID						
Application Number:	10/630649 *10/630649*						
Date:	2003-07-29						
First Named Applicant:	William Dale Jones						
Confirmation Number:	8266						
Attorney Docket Number:							
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>							
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Submitted by:	Elec. Sign.	Sign. Capacity					
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney					

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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID						
Application Number:	10/630649	*10/630649*					
Confirmation Number:	8266						
First Named Applicant:	William Jones						
Attorney Docket Number:							
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	3	5928389	1999-07-27	Jevtic			
	4	5932100	1999-08-03	Yager et al.			
	5	5934856	1999-08-10	Asakawa et al.			
	6	5934991	1999-08-10	Rush			
	7	5944996	1999-08-31	DeSimone et al.			

8	5955140	1999-09-21	Smith et al.
9	5965025	1999-10-12	Wal et al.
10	5976264	1999-11-02	McCullough et al.
11	5979306	1999-11-09	Fujikawa et al.
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13	5981399	1999-11-09	Kawamura et al.
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15	5992680	1999-11-30	Smith
16	5994696	1999-11-30	Tai et al.
17	6001133	1999-12-14	DeYoung et al.
18	6005226	1999-12-21	Aschner et al.
19	6017820	2000-01-25	Ting et al.
20	6024801	2000-02-15	Wallace et al.
21	6029371	2000-02-29	Kamikawa et al.
22	6035871	2000-03-14	Eul-Yeol
23	6037277	2000-03-14	Masakara et al.
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25	6056008	2000-05-02	Adams et al.
26	6063714	2000-05-16	Smith et al.
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28	6077053	2000-06-20	Fujikawa et al.
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30	6082150	2000-07-04	Stucker
31	6085935	2000-07-11	Malchow et al.
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33	6099619	2000-08-08	Lansbarkis et al.
34	6100198	2000-08-08	Crieger et al.
35	6110232	2000-08-29	Chen et al.
36	6114044	2000-09-05	Houston et al.
37	6128830	2000-10-10	Bettcher et al.
38	6140252	2000-10-31	Cho et al.
39	6145519	2000-11-14	Konishi et al.

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43	6171645	2001-01-09	Smith et al.	B1
44	6186722	2001-02-13	Shirai	B1
45	6200943	2001-03-13	Romack et al.	B1
46	6203582	2001-03-20	Berner et al.	B1
47	6216364	2001-04-17	Tanaka et al.	B1
48	6224774	2001-05-01	DeSimone et al.	B1
49	6228563	2001-05-08	Starov et al.	B1
50	6228826	2001-05-08	DeYoung et al.	B1

Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current electronic filing contains part 5 out of a total of 7 electronic filings.

Signature

Examiner Name	Date



UNITED STATES PATENT AND TRADEMARK OFFICE
ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1
Stylesheet Version v1.1.1

Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID										
Submission Type:	Information Disclosure Statement										
Application Number:	10/630649	*10/630649*									
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ICON1	8266										
ISYS5	Filename= N/A BusinessRule= Validation System/Function Call Information. #Supporting Msg:Server unable to validate the Confirmaton/Application numbers at this time. They will be checked by PTO personnel later.										
First Named Applicant:	William Jones										
Attorney Docket Number:											
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Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID						
Application Number:	10/630649						
Date:	2003-07-29						
First Named Applicant:	William Dale Jones						
Confirmation Number:	8266						
Attorney Docket Number:							
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Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney					

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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Stylesheet Version v18.0

Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID						
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Confirmation Number:	8266						
First Named Applicant:	William Jones						
Attorney Docket Number:							
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	4	6239038	2001-05-29	Wen	B1		
	5	6241825	2001-06-05	Wytman	B1		
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9	6255732	2001-07-03	Yokoyama et al.	B1
10	6270531	2001-08-07	DeYoung et al.	B1
11	6270948	2001-08-07	Sato et al.	B1
12	6277753	2001-08-21	Mullee et al.	B1
13	6284558	2001-09-04	Sakamoto	B1
14	6286231	2001-09-11	Bergman et al.	B1
15	6305677	2001-10-23	Lenz	B1
16	6306564	2001-10-23	Mullee	B1
17	6319858	2001-11-20	Lee et al.	B1
18	6331487	2001-12-18	Koch	B1
19	6334266	2002-01-01	Moritz et al.	B1
20	6344174	2002-02-05	Miller et al.	B1
21	6344243	2002-02-05	McClain et al.	B1
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36	6486078	2002-11-26	Rangarajan et al.	B1
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49	6562146	2003-05-13	DeYoung et al.	B1
50	6564826	2003-05-20	Shen	B1

Remarks

Note: Remarks are not for responding to an office action.

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Signature

Examiner Name	Date

**UNITED STATES PATENT AND TRADEMARK OFFICE
ACKNOWLEDGEMENT RECEIPT**

Electronic Version 1.1

Worksheet Version v1.1.1

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Title of Invention	CONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT WITH A FLUID	
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Date:	2003-07-29	
First Named Applicant:	William Dale Jones	
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Submitted by:	Elec. Sign.	Sign. Capacity
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney

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ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v1.8

Stylesheet Version v1.8.0

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InventionCONTROL OF FLUID FLOW IN THE PROCESSING OF AN OBJECT
WITH A FLUID

Application Number: 10/630649 *10/630649*

Confirmation Number: 8266

First Named Applicant: William Jones

Attorney Docket Number:

Search string: (5672204 or 5817178 or 6508259 or 20010019857 or 20010024247 or 20010041455 or 20010041458 or 20020001929 or 20020055323 or 20020074289 or 20020081533 or 20020088477 or 20020098680 or 20020106867 or 20020112740 or 20020112746 or 20020115022 or 20020117391 or 20020123229 or 20020127844 or 20020132192 or 20020141925 or 20020142595 or 20020150522 or 20030003762 or 20030008238 or 20030008518 or 20030013311 or 20030036023 or 20030047533).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

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	1	5672204	1997-09-30	Habuka			
	2	5817178	1998-10-06	Mita et al.			
	3	6508259	2003-01-21	Tseronis et al.	81		

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

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1	20010019857	2001-09-06	Yokoyama	AI
2	20010024247	2001-09-27	Nakata	AI
3	20010041455	2001-11-15	Yun et al.	AI
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8	20020081533	2002-06-27	Simons et al.	AI
9	20020088477	2002-07-11	Cotte et al.	AI
10	20020098680	2002-07-25	Goldstein et al.	AI
11	20020106867	2001-09-27	Yang et al.	AI
12	20020112740	2002-08-22	DeYoung et al.	AI
13	20020112746	2002-08-22	DeYoung et al.	AI
14	20020115022	2002-08-22	Messick et al.	AI
15	20020117391	2002-08-29	Beam	AI
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17	20020127844	2002-09-12	Grill et al.	AI
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Remarks

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Signature

Examiner Name	Date